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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of

New York, New York

Toshinori Ota et al.

Date: August 29, 2006

Serial No.: 10/555,855

Group Art Unit: 1753

Filed: November 7, 2005

Examiner: ---

For: THERMOELECTRIC SEMICONDUCTOR MATERIAL, THERMOELECTRIC SEMICONDUCTOR ELEMENT USING THERMOELECTRIC SEMICONDUCTOR MATERIAL, THERMOELECTRIC MODULE USING THERMOELECTRIC SEMICONDUCTOR ELEMENT AND MANUFACTURING METHOD FOR SAME

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

**SUBMISSION OF INFORMATION DISCLOSURE STATEMENT**

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:  
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Respectfully submitted,

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August 29, 2006

Date of Signature

RCF:bar  
Enclosures

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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /G.M./<sup>1</sup>

Rec'd date: 09/01/2006

10555855 - GAU: 1795

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**APPLICANT'S ART  
CITATION**  
(Use several sheets if necessary)

Application 10/555,855

OFGS File No. P/2850-120

Applicant Toshinori OTA et al.

Filing Date November 7, 2005

Group Art Unit 1753

**U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)**

Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
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Hiroshi Kato and Keiji Yoshikawa, "Elastic Constants of Al-Cu Alloys Containing Columnar Crystals" April 1981, Journal of the Society of Materials Science, Volume 30, No 331.

Examiner	/Golam Mowla/	Date Considered	02/23/2010
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

007775941 ALL REFERENCES CONSIDERED<sup>3</sup> EXCEPT WHERE LINED THROUGH. /G.M./